

Electronic Patent Application Fee Transmittal

Application Number:	10733201			
Filing Date:	09-Dec-2003			
Title of Invention:	Atomic layer deposition method of depositing an oxide on a substrate			
First Named Inventor/Applicant Name:	Garo J. Derderian			
Filer:	Mark S. Matkin/Lori Tetrault			
Attorney Docket Number:	MI22-2402			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				810